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CENTRAL FAX CENTER****MAR 13 2007****IN THE UNITED STATES PATENT AND TRADEMARK OFFICE**

Applicant(s): Liu	
Application No.: 10/634,964	Art Unit: 1765
Filed: 8/5/2003	Examiner: Patricia A. George
Title: CHEMICAL MECHANICAL PLANARIZATION COMPOSITIONS FOR REDUCING EROSION IN SEMICONDUCTOR WAFERS	
Attorney Docket No.: 02039US	
Commissioner for Patents P.O. Box 1450 Alexandria, VA 22313-1450	

**RESPONSE AFTER FINAL REJECTION**

Dear Sir:

In response to the Office Action of February 5, 2007, having a shortened statutory deadline of May 5, 2007, please amend the specification as follows.

Please  
Do NOT Enter  
3-23-07